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Large area molybdenum disulphide-epitaxial graphene vertical Van der Waals heterostructures

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Two-dimensional layered transition metal dichalcogenides (TMDCs) show great potential for optoelectronic devices due to their electronic and optical properties. A metal-semiconductor interface, as epitaxial graphene - molybdenum disulfide (MoS_2), is of great interest from the standpoint of fundamental science, as it constitutes an outstanding platform to investigate the interlayer interaction in van der Waals heterostructures. Here, we study large area MoS_2 -graphene-heterostructures formed by direct transfer of chemical-vapor deposited MoS_2 layer onto epitaxial graphene/SiC. We show that via a direct transfer, which minimizes interface contamination, we can obtain high quality and homogeneous van der Waals heterostructures. Angle-resolved photoemission spectroscopy (ARPES) measurements combined with Density Functional Theory (DFT) calculations show that the transition from indirect to direct bandgap in monolayer MoS_2 is maintained in these heterostructures due to the weak van der Waals interaction with epitaxial graphene. A downshift of the Raman 2D band of the graphene, an up shift of the A_{1g} peak of MoS_2 and a significant photoluminescence quenching are observed for both monolayer and bilayer MoS_2 as a result of charge transfer from MoS_2 to epitaxial graphene under illumination. Our work provides a possible route to modify the thin film TMDCs photoluminescence properties via substrate engineering for future device design.

The study of graphene, a two dimensional (2D) atomic crystal formed of carbon atoms arranged in a honeycomb structure, is one of the hottest topics in material science due to its unique capabilities^{1,2}. The importance of graphene not only lies in its properties but also on the fact that it opened the way and promoted the synthesis of many other 2D materials³. The last 10 years of research on graphene have led to many methods for synthesizing, transferring, manipulating and characterizing the properties of this 2D material, which can be applied to all layered van der Waals (vdW) materials. As one has full control of the 2D crystals, one can also create a stack of these crystals in a completely new heterostructures. Since the portfolio of the original 2D crystals is very rich⁴⁻⁶, a new world of materials is accessible. Combining different 2D layers with complementary characteristics can lead to new vdW heterostructures with tunable properties leading to an outstanding range of possible applications^{7,8}. Among these systems, the combination of a transition metal dichalcogenide (TMDCs) such as MoS_2 and graphene, forming a heterostructure is very interesting, since it combines the excellent optical properties of MoS_2 and the high mobility and transparency of graphene⁹⁻¹².

One well-established method to produce high quality wafer-scale monolayer graphene is the epitaxial approach based on the graphitization of the Si face of SiC^{13,14}. A considerable advantage of this technique lies in the fact that the wide band gap semiconductor SiC wafers can be employed as a substrate, so that no additional transfer step is required to conduct electrical or optical measurements. To our knowledge, until now there are few works discussing the possibility of growing TMDCs materials (MoS_2 or WS_2) on epitaxial graphene/SiC¹⁵⁻¹⁸.

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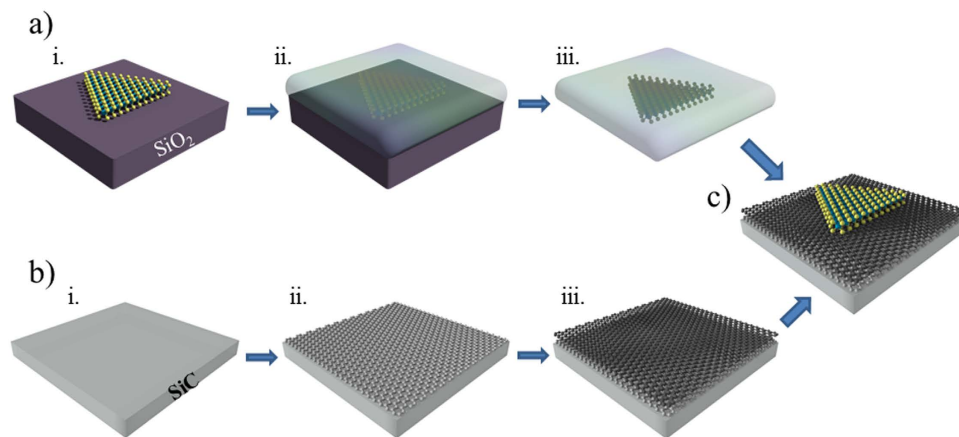


Figure 1. Schematic transfer process of MoS₂ on epitaxial graphene: (a) i. Growth of MoS₂ on Si/SiO₂. ii. Coating of PMMA on the top of the sample. iii. KOH etching of SiO₂ substrate. (b) i. 4H-SiC substrate. ii. Interface layer. iii. Monolayer epitaxial Graphene. (c) Monolayer MoS₂ on epitaxial graphene.

In particular a direct growth approach by Chemical Vapor Deposition (CVD)^{15,16,18–21} or metal-organic chemical vapour deposition (MOCVD)¹⁷ is generally used. Even if the authors obtained high quality interfaces between TMDCs film and graphene, the direct growth method suffers of the fact that the obtained TMDC grain size is small (ranging from hundreds of nm to few microns). However the possibility to obtain large area TMDCs/graphene heterostructures is important for a large variety of *in situ* characterization techniques, and is also a basic requirement for realistic applications. Recently Han *et al.* developed a novel seeded CVD patterned growth method to obtain highly crystalline MoS₂ flakes on oxidized silicon substrate²². MoS₂ grown by this approach has high crystallinity, with large flakes (between 20–100 μm) and electrical and optical properties comparable to exfoliated material. These CVD-grown flakes are suitable for transfer onto epitaxial graphene/SiC substrate in order to obtain large area of MoS₂/graphene heterostructures. Using a transfer process (see results and discussion and Fig. 1(a)) we have obtained monolayer and bilayer MoS₂/graphene heterostructures, allowing the study of interlayer interaction between TMDCs materials and graphene on a large scale, using several complementary techniques. Angle resolved photoemission spectroscopy (ARPES) measurements were used to study the electronic structure of the MoS₂/epitaxial graphene heterostructure. Due to a weak interlayer coupling the electronic structure of graphene and MoS₂ are well retained in their respective layers. However the band alignment in the MoS₂/graphene heterostructure allows under illumination a charge transfer process from MoS₂ to graphene. This is revealed by a downshift of the graphene 2D Raman bands, an upshift of the A_{1g} Raman band of MoS₂, and a strong quenching of photoluminescence (PL) of MoS₂/graphene heterostructure. Complementary we performed photocurrent measurements to elucidate how the presence of the semiconductor affects the photoconductive properties of graphene. In that respect, this work may open a new way in graphene optoelectronics by modulating the graphene photoelectric response through 2D materials interfacing.

Results and Discussions

TMDCs/graphene heterostructures were made from MoS₂ flakes grown by chemical vapor deposition on oxidized silicon substrates that were then transferred onto epitaxial graphene grown on SiC(0001) (Fig. 1(a)). The graphene underlayer used in this study was obtained by annealing 4H-SiC(0001) (see methods) (Fig. 1(b)i–iii). The CVD growth procedure of MoS₂ on SiO₂ results in characteristic single-crystal domains shaped as well-defined equilateral triangles²² (Figure S1). The single-crystal flakes with mono, bi and multilayer thicknesses were identified by their optical contrast and characteristic triangular shape, and further confirmed by micro-Raman, and micro photoluminescence (micro-PL) measurements. For the transfer step, we spin-coated PMMA onto the MoS₂ flakes and peeled them off from the SiO₂ substrate by wet etching in KOH solution (Fig. 1(a)ii,iii). Afterward, we transferred the PMMA/MoS₂ layer onto the graphene/SiC substrate (Fig. 1(c)). We finally removed the PMMA using acetone. Due to the high density of MoS₂ flakes on the Si/SiO₂ substrate (50% of the total area of the sample), we were able to obtain several flakes with various stacking order and orientation in a single transfer step (Fig. 2(a)). The MoS₂ domains transferred onto the graphene retain their triangular shapes with lateral sizes of ~20 to ~100 μm. To further clean the surface and interface of the MoS₂/graphene heterostructure, we annealed the samples at T = 300 °C for 30 mn in UHV (base pressure below P ~ 10⁻¹⁰ mbar). For the following experiments, the monolayer, bilayer and multilayer coverage was estimated from optical analysis to be around 83%, 15% and 2% respectively.

In order to better understand the electronic properties of the MoS₂/graphene/SiC heterostructure, we measured its band structure by angle-resolved photoemission spectroscopy (ARPES) at the Cassiopée beamline of Synchrotron Soleil. The small x-ray spot size (50 × 50 μm²) allowed the measurement of the band structure of a single flake (monolayer or bilayer) forming the MoS₂/graphene heterostructure. The photoelectron intensity is presented in Fig. 2(b) as a function of energy and k-momentum, along the K'–Γ–K direction of the first graphene Brillouin zone. The second-derivative spectrum in Fig. 2(c) is provided to enhance the visibility of the band structure. The zero of the binding energy (i.e., the Fermi level) was determined by fitting the leading edge of

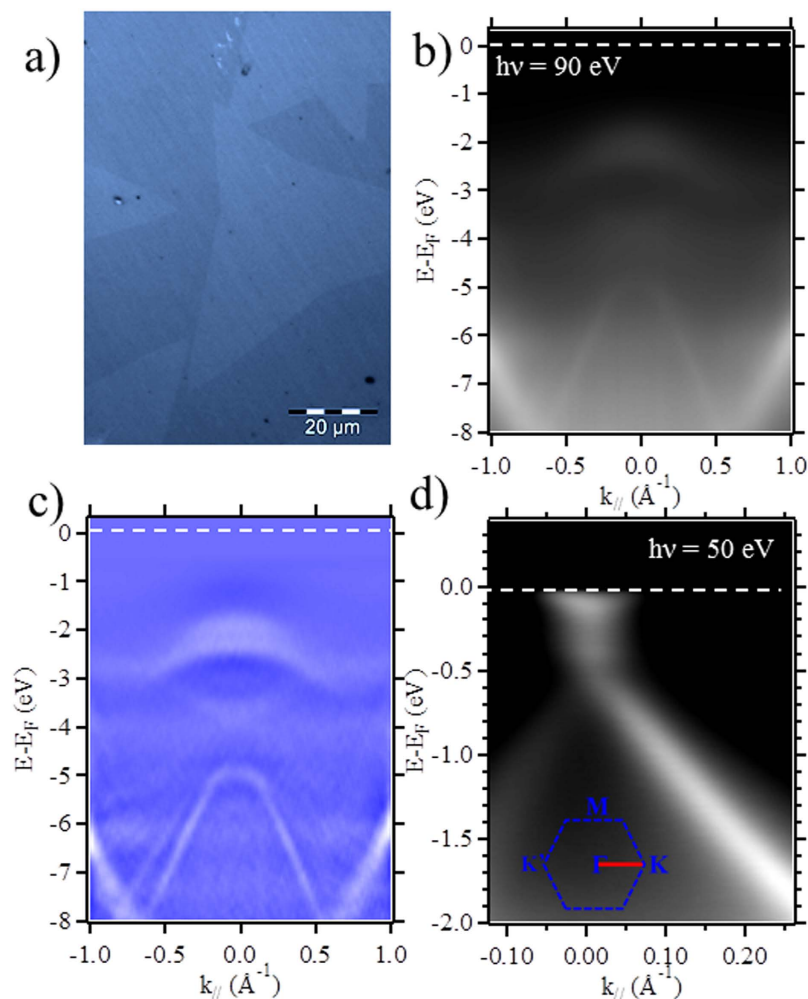


Figure 2. ARPES measurement for monolayer and bilayer MoS₂/graphene heterostructures: **(a)** typical optical image of the MoS₂ transferred on epitaxial graphene layer, **(b)** ARPES measurements of MoS₂/graphene measured at $h\nu = 90$ eV along to the K'TK direction of graphene Brillouin zone, and **(c)** Second-derivative spectra of **(b)** to enhance the visibility of the bands. **(d)** ARPES spectrum around the K point of graphene of the MoS₂/graphene heterostructure at $h\nu = 50$ eV. The white dotted lines in panels **(b–d)** indicate the Fermi level position.

the graphene layer at the same photon energies and under the same experimental conditions. Beside the typical linear dispersion of the π bands of graphene, a new set of bands is visible at the Γ point of the Brillouin zone independently of the orientation angle between the flake and the graphene underlayer, which is the signature of MoS₂ valence band. A close inspection of the K point of graphene Brillouin zone is shown in Fig. 2(d). This spectrum is obtained orienting the sample along the Γ -K direction of the graphene Brillouin zone. In this case the mismatch angle between MoS₂ flake and graphene underlayer is critical. In order to obtain a perfect alignment of the Brillouin zone of the two materials we need a mismatch angle of zero degree. As we can see in Fig. 2(d), along the Γ -K direction, we only see the graphene signature. The two spin split bands expected at the K(K') point^{23,24} of MoS₂ are not visible indicating a non-zero mismatch angle for this flake. However we clearly see the graphene band structure, in particular the π bands of graphene preserve their linearity characteristic of a massless Dirac fermions signature, indicating a high structural quality of the MoS₂/graphene heterostructure. Moreover, similar to pristine monolayer graphene, the Dirac point (E_D) is located at 0.3 eV below the Fermi level (FL). From a linear fit, using the relation $E = \hbar v_F k$, we obtain the value of the Fermi velocity $v_F \sim 1.1 \times 10^6$ m/s, which matches the expected value for monolayer graphene on SiC. As the linear dispersion and Fermi velocity of the pristine graphene is preserved in the MoS₂/graphene heterostructure, we can infer that the MoS₂ transfer does not affect the electronic structure of monolayer graphene in the heterostructure formation. In addition, this feature is expected theoretically since in van der Waals heterostructures, the superposition of each layer electronic structure constitutes a good approximation of the electronic structure of the multilayer. Differently from previous work of Diaz *et al.* no signature of interlayer hybridization²⁵ is present on the π -band of graphene. This is probably due to the mismatch angle between the MoS₂ flake and the graphene underlayer. However identifying the dependence of this effect on the mismatch angle would clearly require a further work and go much beyond the main objective

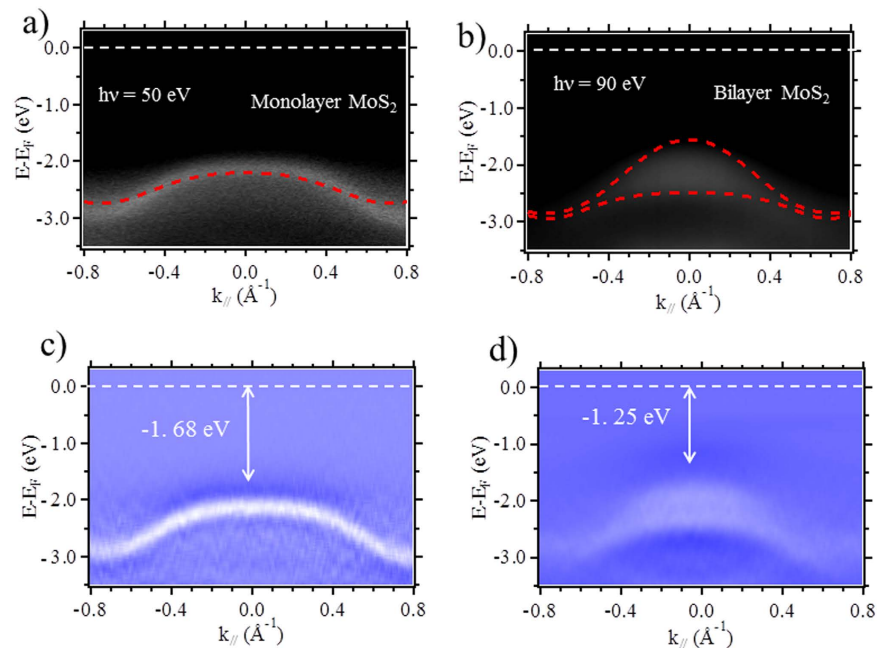


Figure 3. Electronic structure of monolayer and bilayer MoS₂/graphene heterostructures: **(a,b)** ARPES spectra and calculated band structures (red dotted lines) of monolayer and bilayer MoS₂ thin films at $h\nu = 50$ and 90 eV respectively. **(c,d)** Second-derivative spectra of **(a,b)**, respectively, to enhance the visibility of the bands. White dotted lines indicate the Fermi Level position. The arrows indicate the distance of the top of the valence band at the Γ point to the Fermi level.

of this paper. Figure 3(a,b) show a direct comparison of the calculated band structures (see method) and the corresponding ARPES spectra of the monolayer and bilayer MoS₂ on epitaxial graphene, along the K- Γ -K direction in the hexagonal Brillouin zone, the respective second derivative are shown in Fig. 3(c,d). Comparisons with our Density Functional Theory (DFT) calculations clearly show that the monolayer, bilayer-dependent band structure evolution shows excellent agreement with theoretical calculations. Monolayer MoS₂ presents only one band at the Γ point (maximum at Binding Energy (BE) ~ -1.68 eV ± 0.05 eV), and this structure evolves into two branches in the case of bilayer MoS₂ (maximum at BE ~ -1.25 eV ± 0.05 eV). This evolution is representative of the splitting of the bands due to the weak van der Waals interaction between the two MoS₂ layers. The relative position of the top of the valence bands at the Γ point in the bilayer film is closer to the Fermi level than the one obtained from the monolayer (Figure S2). This indicates that MoS₂ undergoes a crossover from an indirect to a direct bandgap in monolayer^{9,23,26}, as predicted theoretically (Figure S3). Indeed, we can observe from Figure S3 (a) to (c) the evolution of the band structure of MoS₂ from monolayer to bi- and trilayer, calculated in DFT. Even though the trilayer MoS₂ has not been considered in details here experimentally, we show the corresponding DFT result to exhibit the evolution of the band structure when considering multilayer MoS₂. In the bi- and trilayer systems, the top of the valence band is located at the Γ point, yielding an indirect band gap with the bottom of the conduction band between the K (K') and Γ points. However, when considering the monolayer band structure, the top of the valence band becomes very flat near the Γ point, leading to a direct gap at the K (K') point. The evolution of the valence band at the Γ point provides a straightforward method to identify the thickness of ultrathin MoS₂ films, and also proves the high quality of MoS₂ transferred on epitaxial graphene. The epitaxial graphene underlayer does not affect the MoS₂ band structure, as expected for a van der Waals heterostructure. However, we do not exclude the presence of the universal buckled form of 2D crystal in our MoS₂ layer³.

To further investigate the electronic properties of mono and bilayer MoS₂/graphene heterostructure, micro photoluminescence (micro-PL) and micro-Raman measurements are performed at room temperature (see method).

The PL spectra present the two characteristic excitonic peaks A and B²⁷⁻³¹ originating from the transition at the K-point of the Brillouin zone (Fig. 4(a)). The spectra also reflect the band structure change from indirect band gap semiconductor of 2ML MoS₂ to direct gap semiconductor in monolayer MoS₂. The PL signal is strongly enhanced when a direct band gap is present. The same behavior was also observed for the as grown MoS₂ on SiO₂ (Figure S4). From the PL spectrum we can extrapolate the band gap value, which corresponds to 1.83 eV in agreement with our DFT calculations and previous experimental works³²⁻³⁶.

In the case of vertical vdW heterostructures, possible PL intensity variations could arise from the interference effects due to different optical constants and thickness of the different layers forming the heterostructure³⁷. Buscema *et al.* defined in their work³⁷ a substrate-dependent enhancement factor Γ^{-1} which allows a normalization procedure of the spectra taking into account the effect of optical interferences³⁷, for the ML MoS₂ on different substrate. Following their results we can see that $\Gamma^{-1} \sim 1$ in the case of SiO₂ substrate. In the case of very thick FLG (15 nm), Γ^{-1} is between 8–14, and presents a huge decrease as the thickness of graphene layer is reduced (~ 2

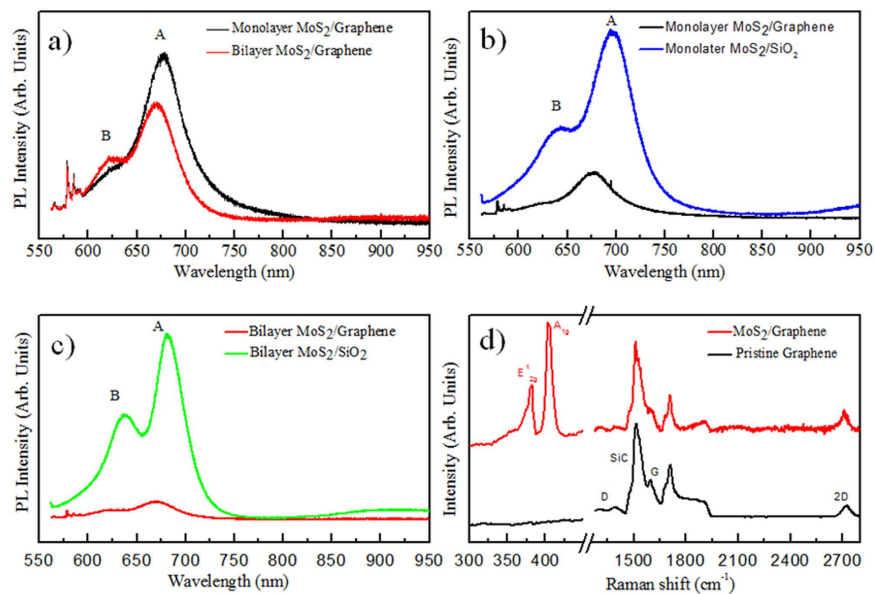


Figure 4. Photoluminescence and Raman spectra for monolayer and bilayer MoS₂/graphene heterostructures: (a) Photoluminescence spectra of MoS₂/graphene heterostructures sample for monolayer (black data) and bilayer (red data) MoS₂, (b,c) Photoluminescence spectra of MoS₂/graphene heterostructures and MoS₂/SiO₂ sample for monolayer (MoS₂/graphene black data and MoS₂/SiO₂ blue data) and bilayer respectively (MoS₂/graphene red data and MoS₂/SiO₂ green data), (d) Graphene wavenumber region of the Raman spectra of pristine graphene (black data) and graphene capped with MoS₂ (red data).

in the case of 5 nm FLG). In our case, we have only one graphene layer, meaning that as for SiO₂ we can suppose $\Gamma^{-1} \sim 1$. Therefore, in both cases we can neglect the effect of optical interferences, and directly compare the PL raw data of MoS₂/SiO₂ and MoS₂/graphene heterostructures as shown in Fig. 4(b,c). In MoS₂/SiO₂ heterostructure strain can exist due to the different thermal expansion coefficients of MoS₂ and the SiO₂ substrate during the MoS₂ flakes growing³⁸. The transfer process on the graphene substrate due to the weak van der Waals forces at the interface releases the lattice strain³⁹. This effect is reflected on the PL spectrum as a blue-shift of the A peak in the MoS₂/graphene heterostructure^{38–40}. Moreover, the PL signal in the case of graphene underlayer is strongly quenched (about 60–70% with respect to the SiO₂ substrate). This phenomenon was explored also as a function of the laser power. In Figure S5 the integrated PL intensity as a function of excitation power is shown. As expected in this range of powers (between 0.5 mW and 25 mW) the MoS₂ PL intensity evolves linearly with increasing laser excitation^{41,42} for both substrate SiO₂ and graphene. But in the case of graphene underlayer the PL signal is quenched for each laser power.

This phenomenon is the signature of electron transfer from MoS₂ to the graphene which hinders the recombination of electron–hole pairs created by the photoexcitation^{32,43}. This electron transfer is not attributed to a strong coupling between MoS₂ and graphene (since we consider a weak van der Waals interaction for this structure), but rather to a standard hopping from an electron in MoS₂ conduction band to an unoccupied state at the same energy in graphene^{43,44}.

Figure 4(d) shows typical Raman spectra of the MoS₂/graphene heterostructure and pristine graphene layer⁴⁵ in the wavenumber range of 300–2800 cm⁻¹. Besides the typical second-order Raman bands that originate from the SiC substrate, the three main structures typical of graphene are present on the pristine graphene and MoS₂/graphene spectra: i) the D band (defect induced mode), ii) the G band (in-plane vibration mode) and iii) the 2D band (two-phonon mode)⁴⁶. In the case of MoS₂/graphene heterostructure within the wavenumber range between 350–450 cm⁻¹ two new peaks are present. These two characteristic features correspond to the in-plane vibration (E_{2g}^1) and out of plane (A_{1g}) of Mo and S atoms in the MoS₂ film^{34,47}. The intensity and Raman shift (Δ) maps of the A_{1g} and E_{2g}^1 are shown in Fig. 5(a). The intensity and the Raman shift Δ increase with the number of MoS₂ layers. The average Raman spectra obtained from each layer are shown in Fig. 5(b). The obtained values of Δ are ~ 19 cm⁻¹, ~ 21 cm⁻¹ and 24 cm⁻¹ corresponding to monolayer, bilayer and multilayer (\sim three layers) MoS₂, respectively^{34,47}. To further examine the role of the interaction with the substrate, we compare the MoS₂ on graphene and on SiO₂ substrates (Fig. 5(c)). After the transfer we observed that the A_{1g} and E_{2g}^1 of the 1ML and 2ML MoS₂ on graphene upshifted by about 4 and 3 cm⁻¹ and 3 and 2 cm⁻¹, respectively, meanwhile the line widths of these peaks, calculated by the full widths at half maximum (*fwhm*) result of a Lorentzian fitting, are narrower than those on SiO₂ (~ 3 cm⁻¹ smaller for 1 ML and ~ 2 cm⁻¹ for the 2 ML for both peaks). As in the case of the PL spectra, the upshift of the in plane Raman mode (E_{2g}^1) is the result of tensile strain release after the MoS₂ transfer on the graphene underlayer^{38–40,48}. The A_{1g} mode shows a weaker strain dependence than the E_{2g}^1 . Consequently, its large upshift upon the transfer can be explained as the result of additional effects: i) the establishment of a van der Waals interaction between MoS₂ and graphene⁴⁷, and ii) a decrease in the electron concentration of the MoS₂⁴⁹. This latest, as shown by the micro-PL measurements is due to a charge transfer under

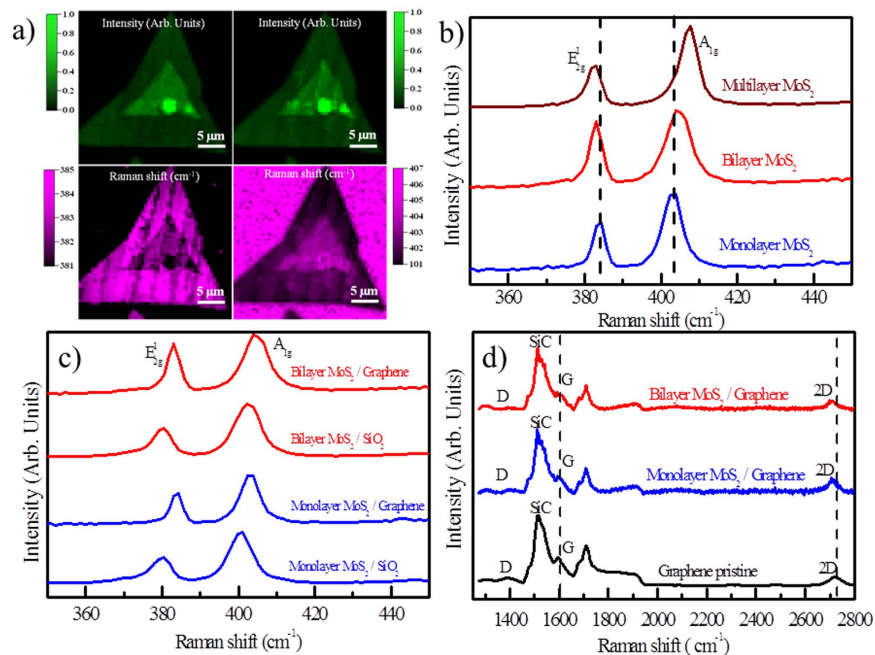


Figure 5. Raman results for monolayer and bilayer MoS₂/graphene heterostructures: (a) Raman maps images of the peaks position and the peaks intensity of the E_{2g}¹ and A_{1g} modes of MoS₂ on epitaxial graphene, (b) Raman spectra of monolayer, bilayer and multilayer MoS₂ on graphene, (c) Comparison of the Raman spectra of monolayer and bilayer MoS₂ on epitaxial graphene and on SiO₂. (d) Raman spectra of pristine graphene and MoS₂/graphene heterostructures sample.

illumination from MoS₂ to graphene. As illustrated by Zhou *et al.*, the important upshift of the A_{1g} is also a signature of the high quality of interface between MoS₂ and graphene⁴⁸. Moreover, when MoS₂ is transferred from SiO₂ to graphene the reduced substrate surface roughness and impurities as well as the similar lattice structure are responsible for the narrowing of the MoS₂ Raman features⁵⁰.

A detailed analysis of the Raman spectra of the monolayer and bilayer MoS₂/graphene heterostructure and pristine graphene layer in the wavenumber range of 1300–2800 cm⁻¹ are shown in Fig. 5(d). As explained before the presence of graphene is indicated by three main structures: i) the D band, ii) the G band and iii) the 2D band. The D peak is small (~1% of the G peak intensity), indicating the high quality of pristine graphene. The intensity of this peak did not increase after transfer, suggesting that the MoS₂ transfer process did not induce defects in the graphene substrate. The Raman spectra of the graphene below MoS₂ domains showed clear differences from that of the free-graphene areas. First, we observe a broad background which increases with higher wavenumbers. This background comes from the PL of MoS₂, which confirms the presence of both graphene and MoS₂ in the measured area. Second, the intensity of the 2D band was reduced by MoS₂. Third, both the G and the 2D bands are shifted. In pristine graphene the 2D band is located at 2722 cm⁻¹ and it is shifted at 2710, and 2708 cm⁻¹ for monolayer and bilayer MoS₂, respectively. There are two factors that can influence the Raman 2D band position: charge transfer^{45,51,52}, and strain^{53–55}. In our Raman measurements, the spectra were taken at room temperature and the laser power was low (~5 mW) to avoid the influence of laser heating. Thus, the observed 2D band downshift does not originate in differences of temperature, which can induce different strain in graphene and MoS₂. It is known that depending on the introduced carriers, the 2D band position shifts differently⁵⁶, with up- and downshifts corresponding to hole and electron doping, respectively⁵¹. Then in MoS₂/graphene heterostructure this downshift indicates an increase in the electron concentration in graphene under illumination (n-type doping)⁵³. This phenomenon is in agreement with the up-shift of the Raman feature of the MoS₂, and confirms that the photoelectrons generated by the Raman laser are transferred from the MoS₂ to graphene. At the same time the G peak presents an upshift. If we focus our attention on monolayer MoS₂/graphene we have an upshift of ~3 cm⁻¹ ± 1 cm⁻¹. From this shift we can obtain a quantitative analysis of the level of electron doping under illumination^{53,57–59}. In fact the G peak frequency blue-shifts linearly with the Fermi level position as $\omega_G - 1580 = |E_F| \times 42 \text{ cm}^{-1} \text{ eV}^{-1}$. From this expression, we estimate the Fermi level position with respect to the Dirac point for pristine graphene and 1ML MoS₂/graphene as $E_F^{Gr} = 330 \pm 10 \text{ meV}$ and $E_F^{1ML/Gr} = 400 \pm 10 \text{ meV}$, respectively. Then the upshift of the G mode of ~3 cm⁻¹ implies a change in the graphene Fermi level of ~70 meV. From these values we can calculate the variation in the n-doping of graphene using the relation $|E_F| = \hbar v_F \cdot \sqrt{\pi |N|}$, and the value of the Fermi velocity obtained before by the linear fit of the Dirac cone in Fig. 2(d) ($v_F = 1.1 \times 10^6 \text{ m/s}$), we obtained an electron density for pristine graphene $|N| \sim 7 \times 10^{12} \text{ cm}^{-2}$ which increases to $|N| \sim 10^{13} \text{ cm}^{-2}$ for 1ML MoS₂/graphene under illumination.

Phototransport properties of the sample are investigated in a planar geometry (i.e. the electrodes are connected to MoS₂ decorated graphene) at room temperature while illuminating the sample with light energy ($\lambda = 405 \text{ nm}$ ($\hbar\nu \approx 3 \text{ eV}$)) above the MoS₂ band gap (Fig. 6(a)). We prepared a lateral device by standard optical

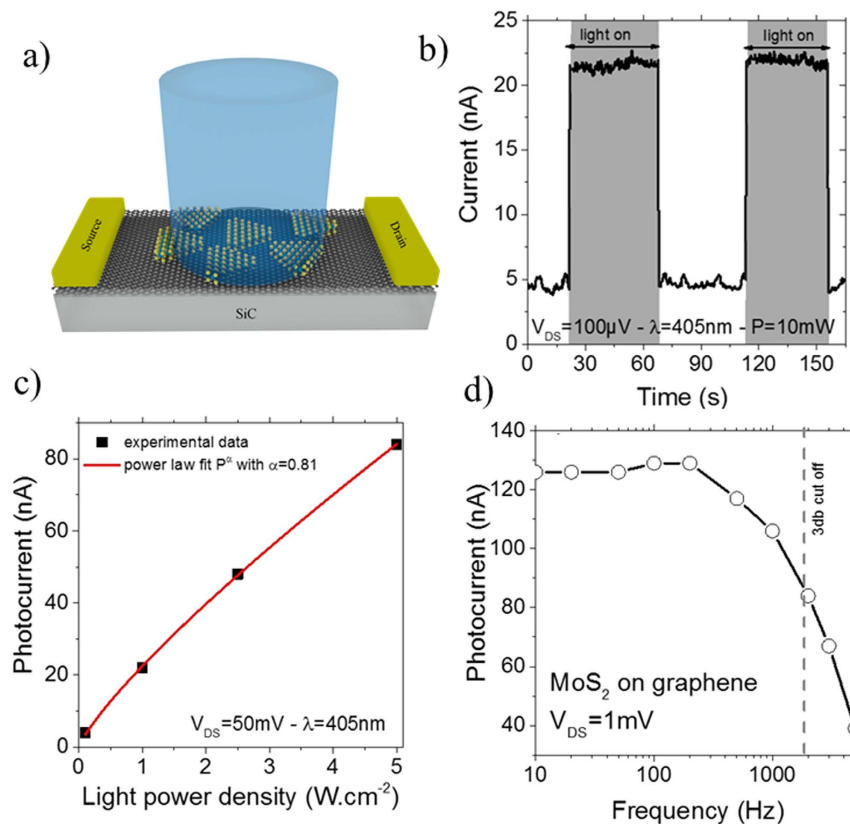


Figure 6. (a) Scheme of the device based on epitaxial graphene MoS₂ flakes, (b) Current as a function of time under constant applied electric field while the light is turned on and off ($V_{DS} = 0.1\text{ mV} - \lambda = 405\text{ nm}$), (c) photocurrent as a function of the light intensity under constant applied electric field ($V_{DS} = 50\text{ mV} - \lambda = 405\text{ nm}$), (d) frequency dependence of the photocurrent under constant applied electric field and light intensity.

lithography. We used dry etching to define a graphene mesa and titanium/gold contacts (20/200 nm). Compared to pristine graphene the photoresponse of the vdW heterostructure is significantly enhanced and a clear modulation of the current is observed under illumination, see Fig. 6(b). The generated photocurrent presents almost no dependence with the applied bias (Figure S6). Similar behavior has already been observed and attributed to thermoelectric effect⁶⁰ and the later result from the inhomogeneous distribution of the MoS₂ flake at the scale of the light source spot. On the other hand, if the size of the device is reduced down to a single MoS₂ flake, the phototransport is very different since we observe a more usual photoconductive behavior, where the slope of the I-V curve change under illumination (Figure S7).

Since the spot diameter of the laser is 1 mm^2 , and the density of the MoS₂ flakes is about 30% of the sample we can estimate the responsivity to be around $6\mu\text{A}\cdot\text{W}^{-1}$. This limited value is the result of the limited absorption of the semiconductor (MoS₂) because of its thickness and limited coverage. The photocurrent generation in TMDC heterostructure generally suffers from two main limitations from an applied point of view, which are their slow response time³⁵ and their strong dependence of the photoresponse with the light intensity^{61,62}. In the following we investigate these two properties. We measured the light intensity dependence of the response and found an almost linear dependence of the current with the photon flux (Φ) see Fig. 6(c). More precisely the power dependence of the current (I) can be fitted using a power law⁴⁴, $I \propto \Phi^{0.8}$. Such dependence is weaker than for large gain system like graphene-PbS quantum dot hybrid system⁶³, which allows using MoS₂ decorated graphene system over a larger range of light flux. While modulating the incident laser intensity thanks to a signal generator we can extract the frequency dependence of the graphene-MoS₂ system⁶⁴. The 3dB cut off frequency is measured to be 2 kHz, see Fig. 6(d).

In summary, we have studied the electronic properties of the wet transfer of large area MoS₂ on epitaxial graphene layer. From the PL, ARPES and micro-Raman data presented in Figs 1–3, it is clear that the MoS₂/graphene heterostructure presents a good long-range order at large scale. Our ARPES measurements on the heterostructure showed that graphene and MoS₂ largely retained their original electronic structure indicating weak van der Waals interactions between the two crystals. The PL quenching in the MoS₂-graphene heterostructure and the upshift of the A_{1g} Raman mode of MoS₂ and the downshift of the 2D Raman mode of graphene confirm the charge transfer between the MoS₂ and graphene layer. Our work suggests that the optical properties of MoS₂ are strongly affected by the underlayer graphene. The fact that an interaction is visible between MoS₂ and graphene is a clear signature of the quality of the wet transfer process and of the absence of interfacial contaminations. Moreover, this charge transfer can be influenced by the underlayer graphene doping, varying the band

alignment in the heterostructure, which should be considered in device design and fabrication. Furthermore, efficient photoresponse was observed on large 2D MoS₂/epitaxial graphene devices, opening a new way in graphene optoelectronics.

Methods

Growth of graphene/SiC(0001). Monolayer graphene studied in this paper is produced via a two-step process beginning with a starting substrate of 4H-SiC(0001)⁶⁵. Prior to graphitization, the substrate is hydrogen etched (100% H₂) at 1550 °C to produce well-ordered atomic terraces of SiC. Subsequently, the SiC sample is heated to 1000 °C at a pressure of about 10⁻⁵ mbar and then further heated to 1550 °C in an Ar atmosphere. This graphitization process results in the growth of an electrically active graphene layer on top of the buffer layer, covalently bound to the substrate⁶⁶. The sample was cooled down to room temperature and transferred *ex-situ* to perform different measurements.

Growth of MoS₂/SiO₂/Si(001). MoS₂/SiO₂ samples were grown via CVD in a 1" quartz tube furnace. Microliter droplets of saturated ammonia heptamolybdate solution were dried onto the corners of a Si/SiO₂ growth substrate that had previously been coated with a layer of sodium cholate (1% solution spin coated 4000 rpm for 60 sec). Sodium cholate is a known growth promoter, acting to increase diffusion of the molybdenum source by increasing the surface adhesive energy relative to the adatom cohesive energy²². The growth substrate was placed in the center of the furnace and heated to 800 °C. A 25 mg sulfur pellet was placed on a piece of silicon and positioned upstream in the furnace such that its temperature was approximately 150 °C. Carrier gas (500 sccm N₂) was used to bring sulfur vapor into the furnace for a 30 min growth period. The sample was then rapidly cooled by cracking open the furnace and sliding it downstream with respect to the quartz tube.

Characterization of MoS₂/graphene heterostructure. The PL measurements were carried out using a confocal commercial Renishaw micro-Raman microscope with a 100× objective and a Si detector (detection range up to ~2.2 eV). The Raman spectra measurements were performed on the same microscope using a 532 nm laser in an ambient environment at room temperature. To ensure the reproducibility of the data, we followed a careful alignment and optimization protocol. In addition, the excitation laser was focused onto the samples with spot diameter of ~1 μm and incident power of ~5 mW. The integration time was optimized to obtain a satisfactory signal-to-noise ratio. We obtained Raman spatial maps by raster scanning with 0.3 μm step size using a precision 2D mapping stage.

The ARPES measurements were conducted at the CASSIOPEE beamline of Synchrotron SOLEIL (Saint-Aubin, France). We used linearly polarized photons of 50 eV and 90 eV and a hemispherical electron analyzer with vertical slits to allow band mapping. The total angle and energy resolutions were 0.25° and 16 meV. The mean diameter of the incident photon beam was smaller than 50 μm. All ARPES experiments were done at room temperature.

For electrical measurements the samples are electrically characterized in air at room temperature. Temporal and power dependence of the current are obtained while biasing the sample and measuring the current with a Keithley 2634B as sourcemeter. Illumination is ensured by a 405 nm blue laser diode with tunable light intensity. The frequency dependence of the photocurrent is measured while the sample is biased using a Keithley 2634B. The output signal is amplified in a Keithley 427 current amplifier and the signal acquired on HP oscilloscope.

DFT calculations. First-principles calculations have been performed using a very efficient DFT localized orbital molecular dynamic technique (FIREBALL)^{67–70}. Basis sets of sp³d⁵ for S and Mo were used with cutoff radii (in atomic units) s = 4.3, p = 4.7, d = 5.5 (S) and s = 5.0, p = 5.6, d = 4.8 (Mo). In this study we have considered standard unit cells of 3, 6 and 9 atoms to describe respectively a mono-bi- and trilayer of MoS₂. Each configuration has been relaxed using a sample of 32 k-points in the Brillouin zone. In case of multilayer MoS₂, we have considered the most stable AB stacking, and the equilibrium distance has been determined using the LCAO-S² + vdW formalism^{71,72}. Finally, a set of 300 special k points along the K'–Γ–K path has been used for the band structure calculations. The corresponding band structures as well as extended atomic representations of the multilayers MoS₂ are provided in Fig. S3(a–f) in the Supplementary Informations.

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Author Contributions

D.P., H.H. and H.S. grows the graphene sample and carried the Raman spectroscopy, C.H.N., A.B. and A.T.C.J. grow the MoS₂ on SiO₂. J.R., F.B., P.F. and A.O. conducted the measurements ARPES. E.L. and H.H. conducted the Phototransport measurement. Y.J.D. carried the DFT calculations. All the authors participated in analyzed the data and writing the paper.

Additional Information

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